



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Hidehiko KIRA, et al.

Group Art Unit: Unassigned

Serial Number: 08/393,677

Filed: February 24, 1995

For: METHOD AND SYSTEM FOR FABRICATING A SEMICONDUCTOR DEVICE

REQUEST FOR STATUS

Honorable Commissioner  
of Patents and Trademarks  
Washington, D.C. 20231

September 5, 1995

Sir:

The undersigned attorney requests the status of the above-identified application.

The application was filed on February 24, 1995 in the U.S. Patent and Trademark Office and to date no Office Action has been received.

In the event any fees are required in connection with this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

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